# Rate capability and magnetic field tolerance measurements of fast timing microchannel plate photodetectors

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#### Abstract

Microchannel plate photodetectors provide both picosecond time resolution and sub-millimeter position resolution, they are attractive sensors for particle identification detectors of future US Electron Ion Collider. We have tested the rate capability and magnetic field tolerance of 6×6 cm<sup>2</sup> microchannel plate photodetectors fabricated at Argonne National Laboratory. The microchannel plate photodetector is designed of low-cost all-glass vacuum package with a chevron pair stack of "next generation" microchannel plates functionalized by atomic layer deposition. The rate capability test was performed with Fermilab 120 GeV primary proton beam, and the magnetic field tolerance test was performed on a solenoid magnetic facility with tunable magnetic field strength up to 4 Tesla. The gain of measured microchannel plate photodetector is stable up to 75 kHz/cm<sup>2</sup>, and varies depending on the applied magnetic field strength and rotation angle relative to the magnetic field direction.

Index terms—Fast timing, Microchannel plate, Pho- 29 todetector, Electron Ion Collider, Particle identification 30 detector, Rate capability, Magnetic field, Rotation angle 31

#### 1. Introduction

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The Electron Ion Collider (EIC) [1] has been recom- 35 mended in the 2015 Long Range Plan for Nuclear Science  $^{36}$ [2] as the highest priority for a new facility construction, 37 with the mapping of the gluon content of nucleons and 38 nuclei as the central goal. Several detector concepts are 39 proposed and designed at Argonne National Laboratory 40 (ANL), Brookhaven National Laboratory (BNL), Thomas 41 Jefferson National Accelerator Facility (JLab) and some 42 other institutes, with slightly different layout. For all 43 these EIC detector designs, excellent particle identifica- 44 tion (PID), especially hadron  $(\pi/K/p)$  separations over a 45 wide range of momentum, is essential for the detailed mea- 46 surements of several processes, such as the semi-inclusive 47 deep inelastic scattering processes. Time-of-flight systems 48 and imaging Cerenkov detectors (RICH, DIRC) [3, 4, 5] 49 are proposed and studied, calling for large area, low cost  $^{50}$ photon sensors with high spatial resolution, high rate ca-51 pability, radiation tolerance, magnetic field tolerance and 52 picosecond timing resolution.

Microchannel plate (MCP) photodetectors are com-54 pact photon sensors, usually with an internal chevron pair  $^{55}$ stack of MCPs, providing both high spatial and temporal 56 resolution in a vacuum package. The Large Area Picosec- 57 ond Photodetector (LAPPD $^{TM}$ ) is the world largest MCP <sup>58</sup> based photodetector with an active area of  $20 \times 20 \text{ cm}^2$  [6]. It is designed of a modular all-glass detector package with the "next generation" MCPs produced by applying resistive and emissive coatings to borosilicate glass capillary array (GCA) substrates through atomic layer deposition (ALD) process. The all-glass design and low-cost "next generation" MCPs provide great advantages to reduce the  $LAPPD^{TM}$  product cost per area compared to other MCP based photodetectors currently available. As a collaborator of the LAPPD project [7], we have built a MCP photodetector fabrication system [8] at Argonne National Laboratory to fabricate 6×6 cm<sup>2</sup> MCP photodetectors with LAPPD design. The fabricated MCP photodetectors were provided to several experiments for early test and adaption of LAPPD detector. The MCP photodetector fabrication system also serves as a R&D platform for LAPPD package design validation and optimization. Several  $6\times6~\mathrm{cm}^2$ MCP photodetectors with standard LAPPD design were successfully fabricated and tested [9, 10, 10], exhibiting high gain over  $10^7$ , overall time resolution of 35 ps and position resolution better than 1 mm. The excellent performance of these  $6 \times 6$  cm<sup>2</sup> MCP photodetectors shows that the low-cost LAPPD $^{TM}$  detector is a promising candidate for EIC PID photo sensors. Performance tests of the MCP photodetectors in high rate, high radiation damage and high magnetic field environments are required to further validate the application of LAPPD $^{TM}$  detectors as EIC PID photo sensors.

In this paper, we describe the current design of  $6\times6$ cm<sup>2</sup> MCP photodetectors fabricated at Argonne National Laboratory, report recent results on the performance tests of these 6×6 cm<sup>2</sup> MCP photodetectors in high rate environment and high magnetic field environment. The direc-

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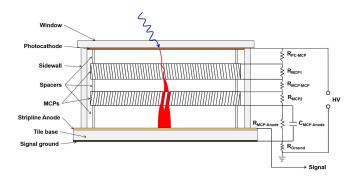


Figure 1: Schematic of MCP-based photodetector assembly (not to scale) and the electrical circuit diagram. External connections to the top and bottom surfaces of the two MCPs are through ultrathin metal shims (not shown) to special extra strip lines on the tile base. The circuit diagram shows connections through side wall in a simplified format.

tion on further optimization of the LAPPD $^{TM}$  design for EIC PID application is also addressed at the end of this paper.

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# 2. Design of the MCP-based photodetector assem-104 bly

Current design of the  $6\times6$  cm<sup>2</sup> MCP photodetector<sub>107</sub> is developed from the original LAPPD internal resistor<sub>108</sub> chain design [11], similar to the current standard design<sub>109</sub> of commercial LAPPD<sup>TM</sup> detectors [12]. Fig. 1 shows<sub>110</sub> a schematic design (not to scale) of current MCP-based<sub>111</sub> photodetector assembly and the electrical circuit diagram.<sub>112</sub>

The MCP photodetector is an all glass body assembly,114 consists of glass base window, top window, side wall, three 115 grid spacers and two MCPs. The sidewall is frit bonded116 onto the base window, with silver stripline anodes printed,117 leading the signals and high voltage connections to outside. 118 Grid spacers are placed between anode and MCPs and top window as insulators to separate these components, they also hold these internal components in place in the vacuum assembly. Four ultra-thin metal shims are applied at the top and bottom surfaces of the two MCPs to lead the electrical connection to external connections, detailed circuit connection inside the vacuum package is described in 123 reference [13]. This independent bias-voltage design pro-124 vides advantage of individually controlling and fine tuning 125 of the bias voltage for each MCP. Bialkali photocathode is  $_{\mbox{\tiny 126}}$ deposited on the inside surface of the top window, and an<sub>127</sub> indium seal is made between the top window and the side-128 wall through a low temperature thermo-compression seal-129 ing process to form a hermetic vacuum detector package. $_{\mbox{\tiny 130}}$ The completed MCP-based photodetector is attached to a<sub>131</sub> custom-made circuit board, providing a permanent mount and firm electrical connections as shown in Fig. 2. Exter-133 nal electrical connections for both signal and high voltage,124 are co are inserted into the external resistor connections  $_{135}$ to serve as high voltage divider, ensuring both MCPs  $\operatorname{work}_{{}_{136}}$ 

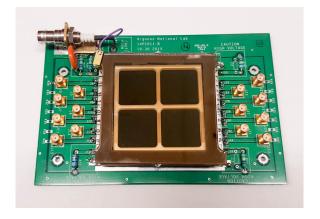


Figure 2: Completed MCP-based photodetector attached to a circuit board, providing firm electrical connections.

at an independently optimized high voltage for best performance. Additional capacitors may also be added across the resistor divider for better signal waveform.

The microchannel plates used in the  $6\times6$  cm<sup>2</sup> MCP photodetector are diced from the "next generation" large area  $(20\times20 \text{ cm}^2) \text{ MCPs } [6, 12]$ , the world largest commercially available MCPs. These "next generation" MCPs are produced through a glass drawing process and functionalized through atomic layer deposition, completely different from the production of traditional leaded glass MCPs. The glass drawing process uses borosilicate glass as tube materials, which is considerably less expensive than the leaded glass and eliminates the chemical etching process required in traditional method, making it much more cost-effective for MCP production. Here, we use standard borosilicate glass MCPs with 20  $\mu$ m pore size, 60:1 L/d (pore length to diameter) ratio and 80 bias angle relative to the MCP surface normal. The two MCPs are placed as the "chevron" configuration in the vacuum package, which reversed the bias angle to  $-8^{\circ}$ .

## 3. Rate capability measurement

The rate capability of MCP-based photodetectors is one of the most critical parameters for applications in high luminosity environment, such as EIC. Due to the high resistive layer coating on ALD functionalized MCPs, the current in the MCP pores may not flow off fast enough when the MCP-based detector is exposed to high particle rates. This effect may cause severe charge saturation, reduce the gain of the MCP-based photodetector and limit the detector performance.

We investigated the rate capability of the  $6\times6$  cm<sup>2</sup> MCP-based photodetectors with 120 GeV/c primary proton beam at the Fermilab Test Beam Facility (FTBF). The beam was delivered as a slow spill with a 4 s duration once per minute with a maximum intensity of  $10^5$  particles per spill. The beam shape is circular with a diameter of 6 mm and a gaussian density profile. The beam intensity was close to a constant during each spill period. On

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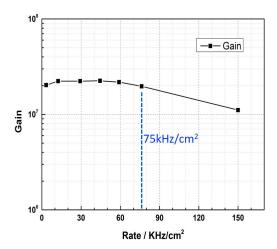


Figure 3: Gain of MCP-based photodetector as a function of the  $120~{\rm GeV/c}$  proton beam flux. The gain of the detector is stable up to beam flux of  $75~{\rm kHz/cm^2}$ , and the gain is still over  $10^7$  at  $150~{\rm kHz/cm^2}$ .

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the beamline, the 120 GeV/c incident proton beam was monitored by an upstream multiwire proportional counter to see the beam profile. Three plastic scintillators in coincidence were used as a trigger and to count the number of incident proton. A light-tight dark box was designed to hold the MCP-based photodetector in the beam path with the detector surface facing the beam direction. High voltage was applied to the MCPs through external resistor voltage divider, and signals from the strip lines were readout through the DT5742 desktop digitizer [14] produced by CAEN (Costruzioni Apparecchiature Elettroniche Nucleari S.p.A.) with a sampling rate of 5 GS/s. The digitizer is based on the switched capacitor array DRS4 (Domino Ring Sampler) chip [15] and have 16 analog input channels and 1 additional analog input for fast trigger.

During our experiment, the 120 GeV/c proton beam 181 intensity was tuned to vary from 500 to 40,000 particles 185 per spill. The beam rate was calculated using the num-186 ber of triggers per spill and was corrected for the size of 187 the beam spot by reconstructing the beam profile. The calculated beam rate varies from 3 to 150 kHz/cm<sup>2</sup> cor-189 responding to the monitored beam particle intensity. Fig. 190 3 shows the gain of the MCP-based photodetector mea-191 sured as a function of the beam rate. The measured gain of the investigated detector is stable up to a beam flux of 75 193 kHz/cm<sup>2</sup> and still over 10<sup>7</sup> when the beam flux reaches 150 194 kHz/cm<sup>2</sup>. Such a high rate capability of the MCP-based 195 photodetector would be sufficient for EIC PID detectors, 196 which are expected to work at a rate environment of xxx 197 Hz/cm<sup>2</sup>.

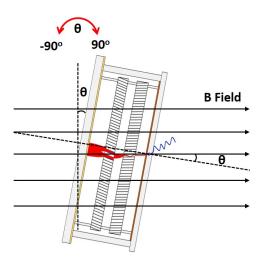


Figure 4: Schematic of the rotation of MCP-based photodetector with angle  $\theta$  relative to the magnetic field direction during the measurement.

#### 4. Magnetic field tolerance measurement

In the EIC detectors, solenoid magnet with field strength of 1.5 Tesla are proposed. The imaging Čerenkov detectors (RICH, DIRC) and time-of-flight systems are designed to cover the area of the barrel and end caps for charged particle  $(\pi/K/p)$  separations. This compact design requires the photo sensors working properly in a harsh environment with magnetic field strength up to 1.5 Tesla.

At Argonne National Laboratory, a decommissioned superconducting magnet from a magnetic resonance imaging (MRI) scanner was acquired to test instruments for the muon g-2 experiment [16]. The magnet provides a large bore with a diameter of 68 cm and a very homogenous field (7 ppb/cm), the magnitude of the magnetic field is tunable up to 4 Tesla. We have built a characterization system compatible with the solenoid magnet to test the performance of the  $6\times6$  cm<sup>2</sup> MCP-based photodetector in strong magnetic field environment. The MCP photodetector was fixed in a custom built non-magnetic, light-tight dark box. The dark box was held on a test platform with the detector surface normal to the direction of magnetic field. The position of the dark box was adjusted so that the center of the MCP photodetector is well aligned with the center of the solenoid magnet. A rotation mechanism was also integrated with the system, allowing rotation of the MCP-based photodetector with angle  $\theta$  as shown in Fig. 4 (not to scale). A 405 nm light-emitting diode (LED) was used as the light source and introduced to the surface of the MCP photodetector through an optical fiber. High voltage was applied to the MCPs from a supply with variable voltage control, and signals from the strip lines were readout through CAEN DT5742 desktop digitizer.

#### 4.1. Magnetic field strength dependence

The dependence of the MCP photodetector performance on the magnetic field strength was done at rotation angle

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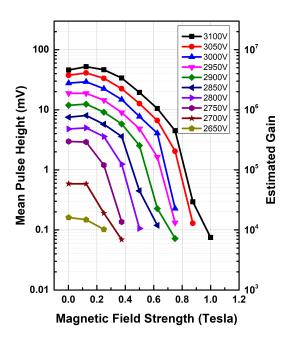


Figure 5: Dependence of the MCP-based photodetector gain on the 234 magnetic field strength at different bias voltages.

 $\theta = 0^{\circ}$ , i.e., the direction of the magnetic field is nor-<sup>236</sup> mal to the surface of the MCP-based photodetector. We237 measured the gain of the investigated MCP photodetector<sup>238</sup> in various magnetic field environment with different bias239 voltages, the results are plotted in Fig. 5. The gain is cal-240 culated based on integrated charge in pulse normalized to<sup>241</sup> single photoelectron. At a fixed bias high voltage, the gain<sup>242</sup> of MCP photodetector increases slightly as the magnetic<sup>243</sup> field strength increases to 0.2 T, and starts to decrease<sup>244</sup> as the magnetic field strength continues to increase, and<sup>245</sup> eventually breaks down at magnetic field strength of  $\sim 0.8246$ T. In the same magnetic field environment, the gain of 247 the MCP photodetector increases as the biased high volt-248 age increases. This behavior is similar to our previous<sup>249</sup> measurement of the MCP photodetectors without apply-250 ing magnetic field.

#### 4.2. Magnetic field angle dependence

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The performance of MCP-based photodetector at dif- $^{254}$  ferent angle was also studied by rotating the MCP pho- $^{255}$  todetector along with angle  $\theta$  relative to the magnetic field  $^{256}$  direction, as shown in Fig 5. We fixed the biased high volt- $^{257}$  age at 3000 V on the photodetector and rotated the pho- $^{258}$  todetector from -90° to 90° for a full angle measurement.  $^{259}$  Fig. 6 shows the gain of MCP photodetector measured as a function of the rotation angle  $\theta$  at magnetic field strength of 0.5 and 0.25 Tesla respectively. The MCP photodetector almost does not provide detectable signals when  $\theta \leq$  -30°  $_{261}$  or  $\theta \geq 30^\circ$ . Within - 30°  $\leq \theta \leq$  30°, there are two gain262 peaks at  $\theta = \pm 8^\circ$ , which are due to the "chevron" config-263 uration of two MCPs inside the photodetector. The gain264 reaches a maximum when the pore of either MCP is well

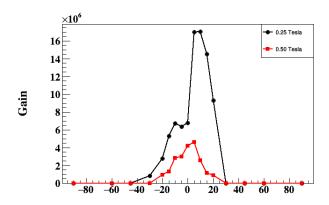


Figure 6: Gain of MCP-based photodetector as a function of rotation angle theta relative to the direction of magnetic field. The two peaks around  $-8^{\circ}$  and  $8^{\circ}$  indicates the effect due to the  $8^{\circ}$  bias angle of the MCPs. Note that the intensities of these two peaks are not the same due to the different effect from top and bottom MCPs.

aligned with the magnetic field direction. Meanwhile, the intensities of the two peaks are different, which is due to the different effect from the top and bottom MCPs.

### 4.3. Design optimization of MCP-based photodetector

In EIC experiment, 1.5 Tesla solenoid magnet will be used for tracking charged particles. The magnetic field tolerance requirement varies from detector to detector depending on their distance and direction to the magnet, and is up to 1.5 Tesla. From our measurement, the  $6\times6~\mathrm{cm}^2$ MCP-based photodetector has shown a good magnetic field tolerance up to 0.8 Tesla, comparable to that of current commercially available MCP-PMTs ( $\sim 1.0 \text{ T}$ ) with similar pore size [17]. Here, we must emphasize that the current LAPPD design is not optimized yet for magnetic field tolerant applications. The distances between the photocathode, MCPs and anode are pretty large in the LAPPD design, e.g., spacings between the photocathode and MCPs are 2 mm and the spacing between the MCP and anode is 3.2 mm [10], these distances should be reduced to minimize the electron transit distance. Meanwhile, MCP photodetectors with smaller pore size MCPs have shown better magnetic field tolerance than the ones with larger pore size MCPs [17, 18, 19]. A redesign of the current LAPPD configuration with smaller pore size (e.g. 10  $\mu$ m or even  $5 \mu m$ ) "next generation" MCPs and reduced distances between the PMT elements would further improve its magnetic field tolerance to the required level.

#### 5. Conclusions

We have described the current design of  $6\times 6$  cm<sup>2</sup> microchannel plate photodetectors with "next generation" MCPs functionalized through atomic layer deposition process. The rate capability and magnetic field tolerance of

these photodetectors were tested at Fermilab 120 GeV pro- $^{323}$  ton beam and Argonne 4 Tesla magnetic field facility re- $^{324}$  spectively. The photodetectors exhibit stable performance  $^{325}$  up to 75 kHz/cm<sup>2</sup> and magnetic field tolerance up to  $0.8_{327}$  Tesla. The magnetic field angle dependence was also mea- $^{328}$  sured, showing enhanced performance at  $\pm 8^{\circ}$  tilt angle  $^{320}$  due to the original MCP  $8^{\circ}$  bias angle. The magnetic field  $^{330}_{331}$  tolerance of these detectors should be further improved by  $^{332}$  applying smaller pore size MCPs and redesign the package  $^{335}$  with reduced distances between the photocathode, MCPs  $^{334}$  and anode.

#### 6. Acknowledgments

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